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Claus Schne Lothar Pfitzr  ** CONTINUING D THIS APPLI  ** FOREIGN APPL GERMANY	eider, ner, E DATA CATI LICA	, Nurnberg, GERMAN' Bubenreuth, GERMA Frlangen, GERMANY; ************************************	NY; * T/EP99/	09410 12/02/1	999	JS			4,
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 08/03/2001									
Foreign Priority claimed				STATE OR COUNTRY GERMANY			TOTAL CLAIMS 31		INDEPENDENT CLAIMS 2
ADDRESS LERNER AND GRI PATENT ATTORNI Post Office Box 248 Hollywood ,FL 330	EYS 80	AND ATTORNEYS AT	ΓLAW						-
TITLE Method and device production	for c	ptically monitoring fab	rication	processes of fi	nely s	tructured	d surface	s in a	semiconductor
RECEIVED No	EES: o o	S: Authority has been given in Paper to charge/credit DEPOSIT ACCOUNT for following:				All Fees  1.16 Fees (Filing)  1.17 Fees (Processing Ext. of time)  1.18 Fees (Issue)  Other Credit			